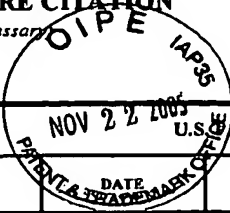


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| INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small> | | | | Docket Number (Optional) NE204-US DIV | | Application Number 10/734,673 | |
| | | | | Applicant(s) Keisuke HAYAKAWA | | | |
| | | | | Filing Date December 15, 2003 | | Group Art Unit 2673 | |



| U.S. PATENT DOCUMENTS | | | | | | | |
|-----------------------|-----|-----------------|------|------|-------|----------|----------------------------|
| *EXAMINER INITIAL | REF | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
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| U.S. PATENT APPLICATION PUBLICATIONS | | | | | | | |
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| FOREIGN PATENT DOCUMENTS | | | | | | | | |
|--------------------------|-----|-----------------|----------|---------|-------|----------|-------------|----|
| | REF | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | Translation | |
| | | | | | | | YES | NO |
| /A.K./ | | 06-202776 | 07/22/94 | JAPAN | | | ABS | |
| /A.K./ | | 09-212285 | 08/15/97 | JAPAN | | | ABS | |
| /A.K./ | | 11-272401 | 10/08/99 | JAPAN | | | ABS | |
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| | | | | | | | | |

| OTHER DOCUMENTS <small>(Including Author, Title, Date, Pertinent Pages, Etc.)</small> | | |
|---|--|---|
| | | Japanese Office Action dated August 23, 2005, with partial English translation. |
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| EXAMINER /Anil Kumar/ | DATE CONSIDERED 06/23/2007 |
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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|--|-----|-----------------|----------|--|-------|---|-------------------------------|
| INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i> | | | | Docket Number (Optional) NE204-USDIV | | Application Number Not yet assigned | |
| | | | | Applicant(s) Keisuke HAYAKAWA | | | |
| | | | | Filing Date Concurrently Herewith | | Group Art Unit Unknown | |
| U.S. PATENT DOCUMENTS | | | | | | | |
| *EXAMINER INITIAL | REF | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
| /A.K./ | | 5,696,982 | 12/09/07 | Tanigawa, et al. | | | |
| /A.K./ | | 5,900,876 | 05/04/99 | Yagita, et al. | | | |
| /A.K./ | | 5,289,569 | 02/22/94 | Taniguchi | | | |
| /A.K./ | | 6,225,996 B1 | 05/01/01 | Gibb, et al. | | | |
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| FOREIGN PATENT DOCUMENTS | | | | | | | |
| | REF | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | Translation YES NO |
| | | 5-165595 | 07/02/93 | Japan | | | YES NO ✓ |
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| OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i> | | | | | | | |
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| EXAMINER | | | | DATE CONSIDERED | | | |
| /Anil Kumar/ | | | | 06/23/2007 | | | |
| <small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small> | | | | | | | |

12/15/03